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Title of Invention	ATOMIC LAYER DEPOSITION APPARATUS				
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First Named Applicant:	Barry Chin				
Attorney Docket Number:	5017Y01				
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Examiner:	Alexander Kosowski				
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RECEIVED FEB 18 2004 Technology Center 2100					
US Patent Documents					
Note: Applicant is not required to submit a paper copy of cited US Patent Documents					
init	Cite.No.	Patent No.	Date	Patentee	Kind
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1	2	6579372	2003-06-17	Park	B2
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